# Filmetrics<sup>®</sup> F20 Thin-Film Analyzer

## Thin-Film Measurements From 1nm to 3mm

Whether you are looking for the thickness, optical properties, or just the reflectance and transmittance of your materials, the F20 has you covered. Set up takes mere minutes by a USB connection, and results are available in under a second. Thanks to its modular nature, the F20 is adaptable to a variety of applications:

- Measure thickness, refractive index, reflectance, and transmittance of:
  - Single or multiple-layer film stacks
  - Freestanding membranes
  - Liquid films or air gaps
- Measurements under many conditions, including:
  - On flat or curved surfaces
  - With a spot-size down to  $20 \mu m$
  - Tabletop, XY mapping, or in-line configurations

All of this functionality is bundled with an intuitive software package and backed by our immediate 24-hour/5-day phone and internet support. That's the Filmetrics advantage! Give us a try!

# **Example Layers**

Virtually any smooth, translucent, or lightly-absorbing film may be measured. This includes most dielectrics and semiconductors. Some examples are:

SiNX	TiO2	DLC
SU-8	Polymers	AIQ
Amorphous Silicon	ITO	CIGS

# **The Filmetrics Advantage**

• World's leader in tabletop thin-film measurement

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FILMETRICS

- 24-hour phone, e-mail, and online support
- Intuitive analysis software standard with every system

# **Additional Features**

- Built-in online diagnostics
- Standalone analysis software included
- Sophisticated history function for saving, reproducing, and plotting results

# **Applications**

#### Semiconductors

- Photoresist
- Process Films
- Dielectrics

#### **Optical Coatings**

- Hardcoat Thickness
- Anti-Reflection
  Coating

- Displays
- OLED
- Glass Thickness
- ITO & Other TCOs

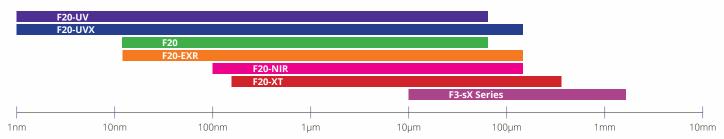
## Biomedical

- Parylene
- Medical Devices



# F20 Thin-Film Analyzer

# **Thickness Measurement Range**



General Specifications	F20-UV	F20-UVX	F20	F20-EXR	F20-NIR	F20-XT
Spectrometer Wavelength Range	190-1100nm	190-1700nm	380-1050nm	380-1700nm	950-1700nm	1440-1690nm
Light Source	External, D2 + Halogen		Internal, Halogen			

Measurement Specifications	F20-UV	F20-UVX	F20	F20-EXR	F20-NIR	F20-XT
Thickness Measurement Range*	1nm-40µm	1nm-250µm	15nm-70µm	15nm-250µm	100nm-250µm	0.2µm-450µm
Min. Thickness to Measure n & k*	50nm	50nm	100nm	100nm	500nm	2µm
Accuracy*: The Greater of	1nm or 0.2%	1nm or 0.2%	2nm or 0.2%	2nm or 0.2%	3nm or 0.4%	5nm or 0.4%
Precision <sup>1</sup>	0.02nm	0.02nm	0.02nm	0.02nm	0.1nm	1nm
Stability <sup>2</sup>	0.05nm	0.05nm	0.05nm	0.05nm	0.12nm	1nm
Spot Size	Standard 1.5mm, Optional Down to 20µm 600µm					
Sample Size	From 1mm to 300mm Diameter and Up					

General Requirements	
Power	100-240VAC, 50-60Hz, 0.3-0.1A
Computer Interface	USB 2.0
Certifications	CE EMC and Safety Directives

Operating System	
PC	Windows 10 - Latest Windows (64-bit)
MAC	OS X Catalina - Latest MAC OS Running Parallels

\* Material dependent

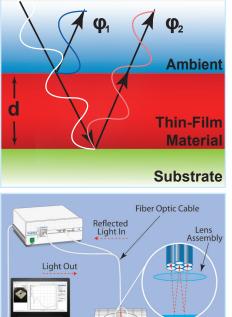
 $^{1}$  1  $\sigma$  of 100 measurements of 500nm SiO\_2-on-Si. Average of 1  $\sigma$  over 20 successive days.

 $^2~2\sigma$  of daily average of 100 measurements of 500nm  $SiO_2$  on-Si over 20 successive days.



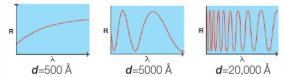
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## **How Does It Work?**



## **Determination of Thickness**

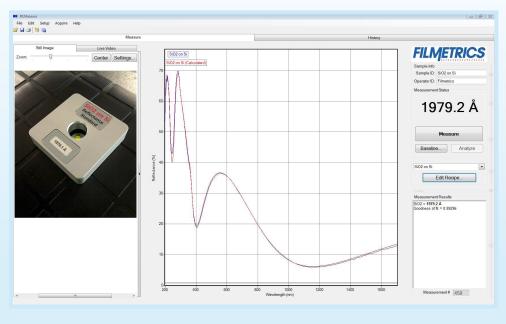
When light encounters an interface between two materials, it is partially reflected. The wave-like nature of light causes reflections from multiple interfaces to interfere with each other, resulting in oscillations in the wavelength spectrum of the reflected light.



From the frequency of these oscillations we determine the distance between the different interfaces and thus the thickness of the materials (with more oscillations meaning greater thickness). Other material characteristics are also measured, such as refractive index and roughness.

# Software Built with the User in Mind

**Reflected Light** 



The FILMeasure software package provides you with an enormous degree of control and is easily adapted to your needs. Doing research? FILMeasure comes with access to more than 1,000 material files, and you can also easily measure your own refractive index values.

Looking for a quality control tool? Integrated access control allows you to lock down your recipes, prohibiting users

from accidentally changing settings and keeping your results stable and reliable. This is just a small selection of the standard features; here are a few more of our favorites:

- 1. Optional SampleCam allows for integrated measurement spot viewing and sample identification.
- 2. Interactive user interface allows you to select the features you'd like to display or hide.
- 3. Comprehensive history function recovers previous results in seconds and tracks and plots statistical information and measurement trends.



# F20 Thin-Film Analyzer

#### **Automate Your Day**

Confirm the uniformity of your coating with the XY10 mapping stage, turning your F20 into a measurement automaton.



#### An Extra Eye on Your Samples

Track your measurements with confidence using the measurement spot-locator function of our SampleCam.



#### **Thinking Small?**

Mount your F20 to almost any microscope with the MA-Cmount-F20KIT. Great for patterned samples.



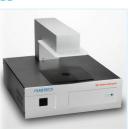
#### **Handling Curved Surfaces**

Make quick work of difficult applications, like curved surfaces or rough substrates, with our CP-1 probe.



## **Transmittance at All Angles**

Use the SS-Trans-Curved to measure the transmittance of flat and curved samples.



### **Measurements Made Even Easier**

Simply set your sample on the CS-1 to get an immediate thickness reading.



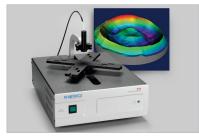
## **Looking to Do More?** Extend your capabilities even further with these related products:



F30 for in-line applications



F40 for microspot measurements



F50 for automated mapping of samples up to 590mm in size



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